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Bib Data Sheet

CONFIRMATION NO. 4482

SERIAL NUMBER 09/866,576	FILING DATE 05/29/2001 RULE	CLASS 257	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. P 281355 EL01019CDC	
APPLICANTS Tadahiro Ohmi, Sendai-Shi, JAPAN; Shigetoshi Sugawa, Sendai-Shi, JAPAN; Katsuyuki Sekine, Sendai-Shi, JAPAN; Yuji Saito, Sendai-Shi, JAPAN;					
** CONTINUING DATA ***** <i>DKO</i>					
** FOREIGN APPLICATIONS ***** <i>DKO</i> JAPAN 11-376170 11/30/1999					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/23/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <i>Allowance</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 17	TOTAL CLAIMS 39	INDEPENDENT CLAIMS 17
Verified and Acknowledged Examiner's Signature <i>Day & One</i> Initials <i>DKO</i>					
ADDRESS 00909					
TITLE Semiconductor device formed on (111) surface of a si crystal and fabrication process thereof					
FILING FEE RECEIVED 2432	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit _____		